

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Atsushi KUROKAWA et al.

Appln. No.:

Filed: HERewith

For: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

* * *

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

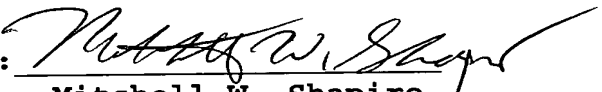
Sir:

Applicants wish to make of record the documents cited in prior Application No. 10/347,806 filed January 22, 2003, whether cited by Applicants or by the Patent Office. The documents are listed on the attached Form PTO-1449.

Respectfully submitted,

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September 30, 2003

FORM PTO-1449				Atty. Docket No. XA-9801A		Appln. No.	
<u>LIST OF DOCUMENTS CITED BY APPLICANT</u>							
				Applicant Atsushi KUROKAWA et al.			
				Filing Date HEREWITH		Group	
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA	5,077,231	12/31/91	Plumton et al.	438	170	
	AB	5,166,083	11/24/92	Bayraktaroglu	438	170	
	AC	5,268,315	12/07/93	Prasad et al.	438	314	
	AD	5,324,671	06/28/94	Bayraktaroglu	438	317	
	AE	5,672,522	09/30/97	Streit et al.	438	312	
	AF						
	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AJ	2001-210723	08/03/01	Japan			Abstract
	AK						
	AL						
	AM						
	AN						
	AO						
OTHER (including author, title, date, pertinent pages, etc.)							
	AP	Chen et al., "High-Speed InGaP/GaAs HBT's Using a Simple Collector Undercut Technique to Reduce Base-Collector Capacitance," <u>IEEE Electron Device Letters</u>, Vol. 18, No. 7, July 1997, pp. 355-357.					
	AQ	Ahmari et al., "InGaP/CaAs Heterojunction Bipolar Transistor Grown on a Semi-Insulating InGaP Buffer Layer," <u>IEEE Electron Device Letters</u>, Vol. 18, No. 11, November 1997, pp. 559-561.					
	AR						
Examiner				Date Considered			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							